## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Patent Application of:		)	Confirmation No.: 4693
Koichiro TANAKA et al.		)	Examiner: Chuong A. Luu
Serial No. 10/787,120		)	Group Art Unit: 2892
Filed	: February 27, 2004	)	
or:	LASER IRRADIATION METHOD,	).	
	LASER IRRADIATION APPARATUS,	)	
	AND METHOD FOR	)	
	MANUFACTURING	)	
	SEMICONDUCTOR DEVICE	)	

## INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

## Dear Sir:

In accordance with the provisions of 37 C.F.R. § 1.56 and 37 C.F.R. § 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. § 1.98(a).

Copies of U.S. patents and U.S. publications are not enclosed in accordance with the Notice published in the Official Gazette on August 5, 2003 entitled Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003, which waives the requirement under 37 C.F.R. § 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. publication.

A payment in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(c).

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§ 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280.

Respectfully submitted,

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